

PATENT ABSTRACTS OF JAPAN(11)Publication number : **2002-015464**(43)Date of publication of application : **18.01.2002**

(51)Int.Cl.

G11B 7/24**C22C 5/08****C23C 14/06****C23C 14/14****C23C 14/34****G11B 7/26**(21)Application number : **2000-395894**(71)Applicant : **KOBE STEEL LTD**(22)Date of filing : **26.12.2000**(72)Inventor : **ONISHI TAKASHI
TAKAGI KATSUHISA
NAKAI JUNICHI
FUJII HIDEO**

(30)Priority

Priority number : **2000130898** Priority date : **28.04.2000** Priority country : **JP****(54) REFLECTING LAYER OR TRANSLUCENT REFLECTING LAYER FOR OPTICAL INFORMATION RECORDING MEDIUM, OPTICAL INFORMATION RECORDING MEDIUM AND SPUTTERING TARGET FOR THE MEDIUM**

(57)Abstract:

PROBLEM TO BE SOLVED: To provide a reflecting layer or a translucent reflecting layer for an optical recording medium having a high reflectance and excellent in durability.

SOLUTION: The reflecting layer or the translucent reflecting layer comprises an Ag-base alloy containing ≥ 0.5 at.% Cu and 0.5-3 at.%, in total, of at least one element selected from the group comprising Nd, Sn and Ge and/or ≥ 0.1 at.% at least one rare earth element.**LEGAL STATUS**

[Date of request for examination] 14.06.2001

[Date of sending the examiner's decision of rejection]

[Kind of final disposal of application other than the examiner's decision of rejection or application converted registration]

[Date of final disposal for application]

[Patent number] 3365762

[Date of registration] 01.11.2002

[Number of appeal against examiner's decision of rejection]

[Date of requesting appeal against examiner's decision of rejection]

[Date of extinction of right]

Copyright (C); 1998,2003 Japan Patent Office